



#11  
IOS  
9-10-02  
ary

Inventor: Kie Y. Ahn et al.

Title: Methods of Forming Assemblies Comprising Silicon-Doped Aluminum Oxide

Assignee: Micron Technology, Inc.

**INFORMATION DISCLOSURE STATEMENT**

References – See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

Respectfully submitted,

Dated: August 19, 2002

Attorney: \_\_\_\_\_

Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711